



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Appl. No. : 10/823,970) Confirmation No. 5318
Applicant : OGAWA, et al.)
Filed : 13 April 2004)
Art Unit : 2818)
Examiner : Hoang, Quoc Dinh)
Attorney)
Docket No. : SPSN-AF01215)
)
For: SEMICONDUCTOR DEVICE HAVING)
A PAD METAL LAYER AND A LOWER METAL)
LAYER THAT ARE ELECTRICALLY)
COUPLED, WHEREAS APERTURES ARE)
FORMED IN THE LOWER METAL LAYER)
BELOW A CENTER AREA OF THE PAD)
METAL LAYER)
_____)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE AND RCE

Dear Sir:

In response to the final Office Action dated October 31, 2006, and the Advisory Action dated February 14, 2007, and coincident with the RCE filed herewith, Applicants respectfully request reconsideration of the above-identified patent application. Please consider the following amendments and remarks for allowance of the above-identified patent application.